

Title: Substrate Processing Apparatus & Maintenance..
Inventor: T. TANAKA et al.
Application No. New application
Docket No. 107350-00008

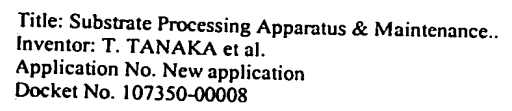
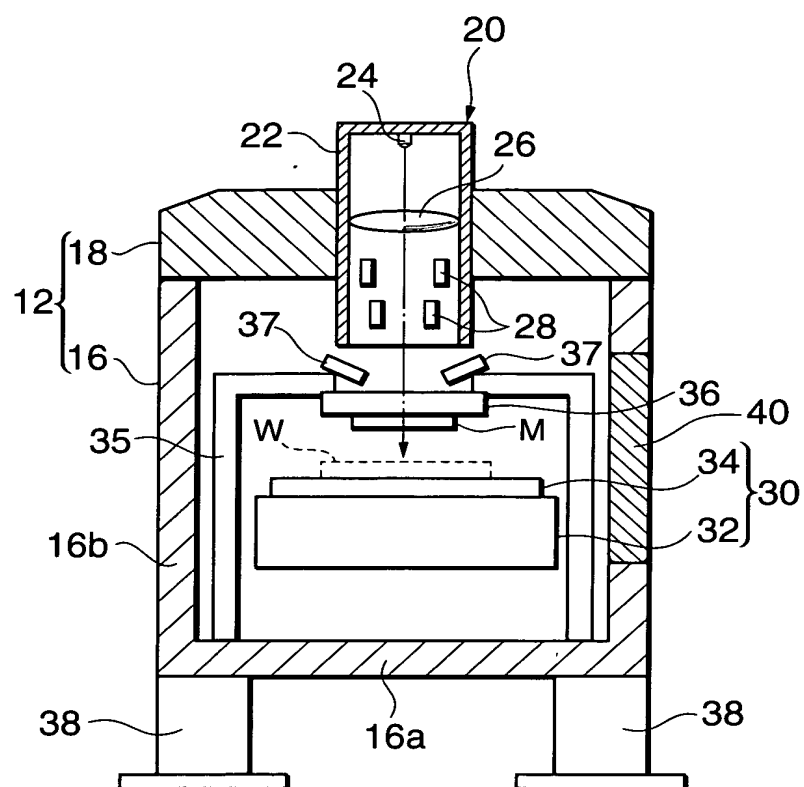


Fig.2



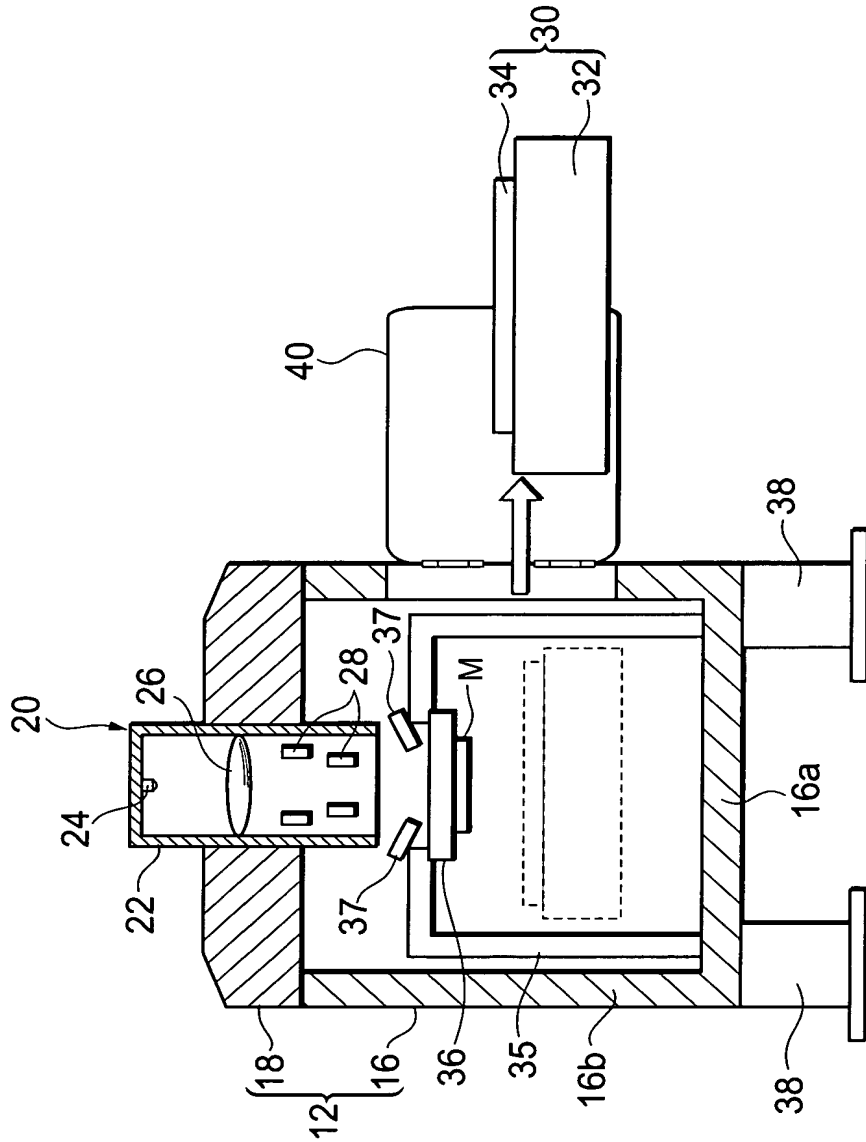


Fig.4

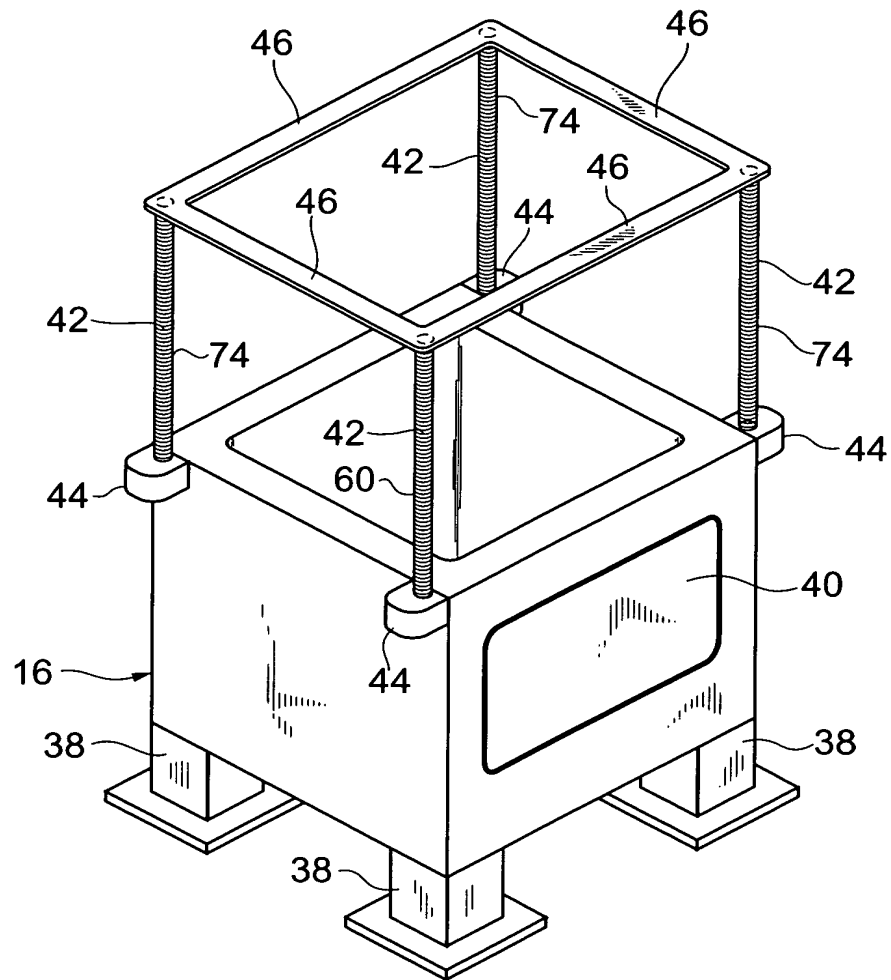


Fig.5

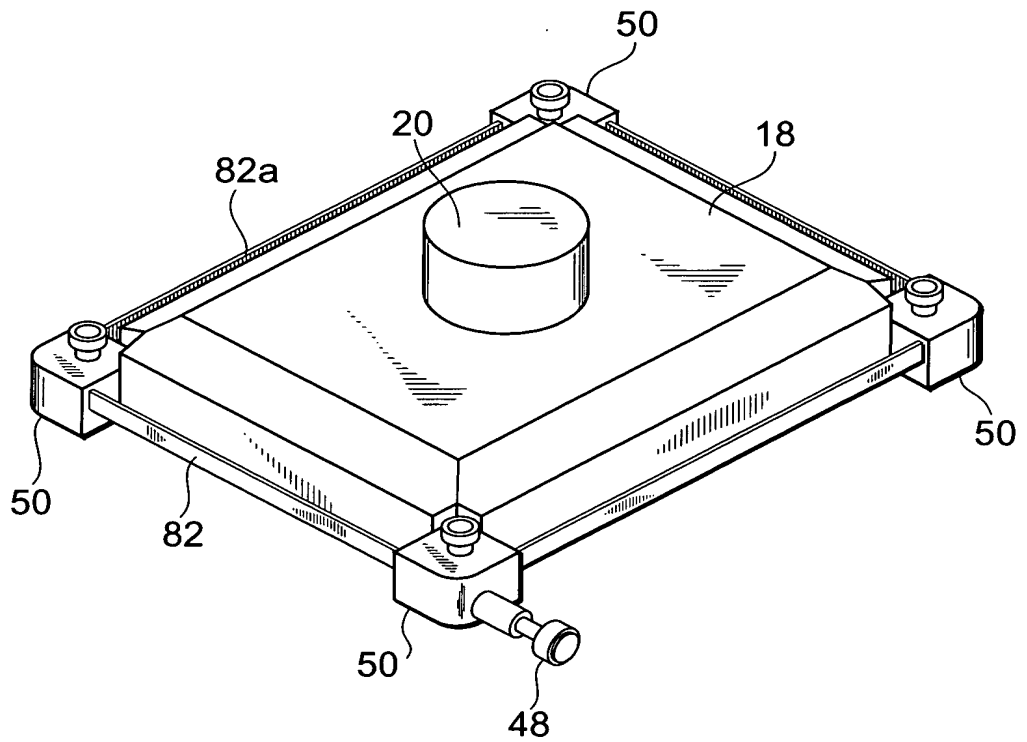




Fig. 6

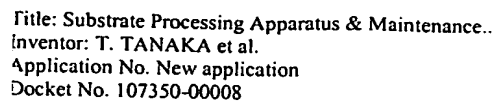
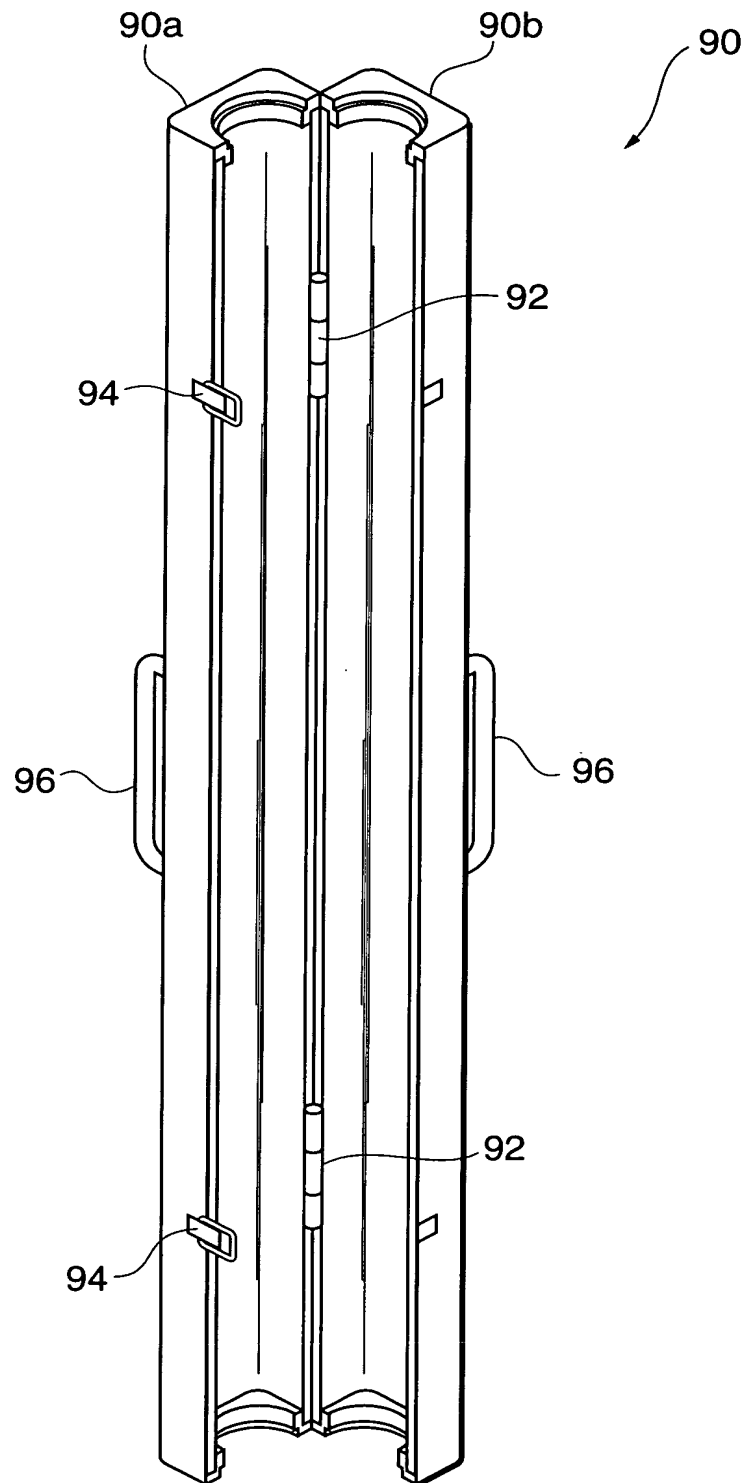


Fig. 7

Fig.8



9/11

Fig.9

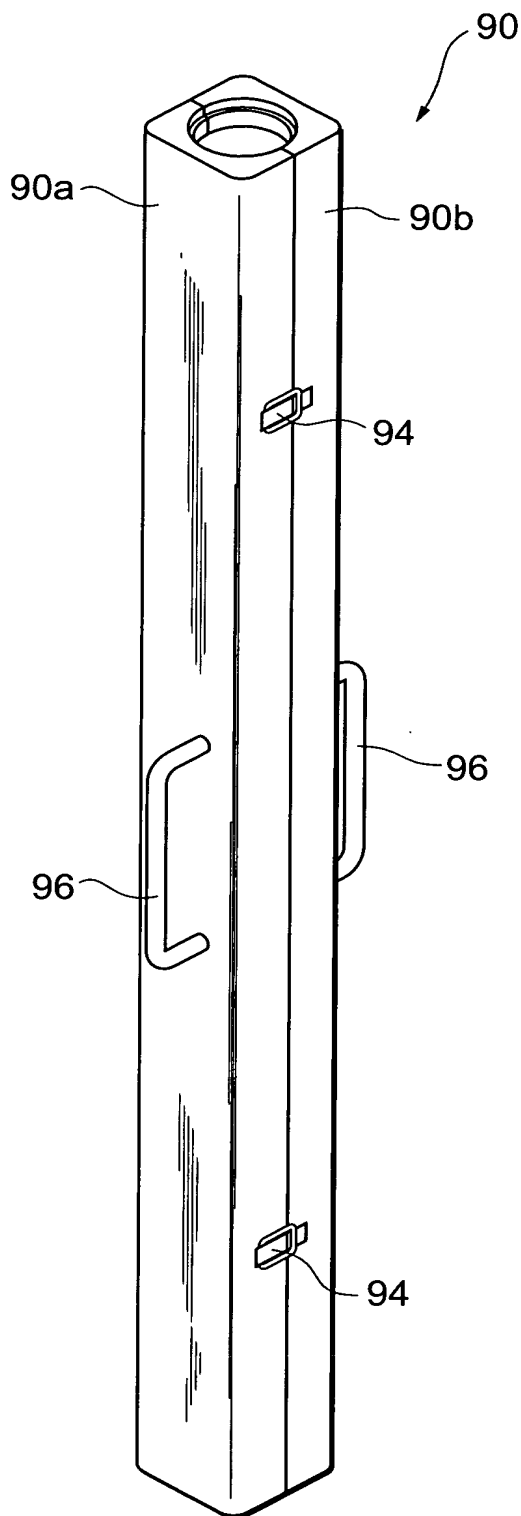


Fig.10

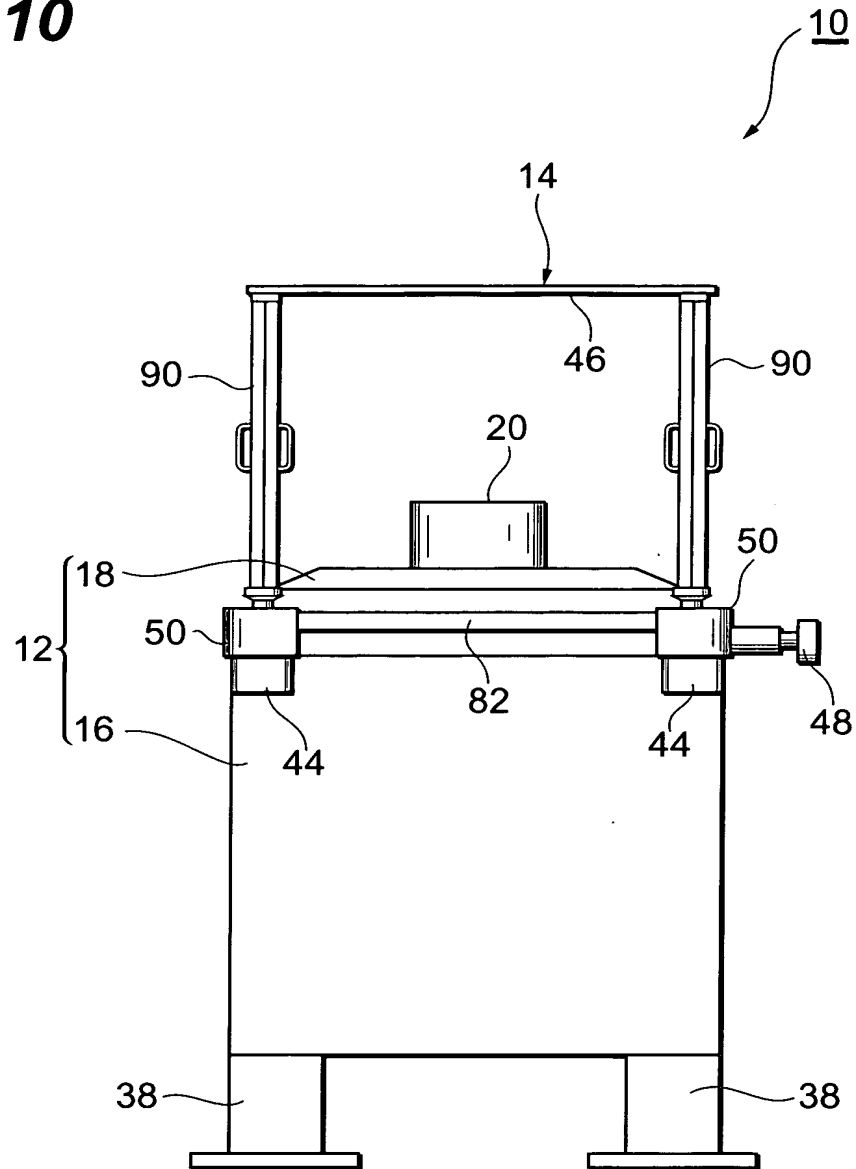


Fig.11

